

Title (en)
Microfabricated elastomeric valve and pump systems

Title (de)
Elastisches Mikropumpen- oder Mikroventilsystem

Title (fr)
Système de micropompes ou soupapes flexibles

Publication
EP 1195523 A3 20030108 (EN)

Application
EP 01128819 A 20000627

Priority
• EP 00305389 A 20000627
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• US 18685600 P 20000303

Abstract (en)
[origin: EP1195523A2] A method of fabricating an elastomeric structure, comprising: forming a first elastomeric layer on top of a first micromachined mold, the first micromachined mold having a first raised protrusion which forms a first recess extending along a bottom surface of the first elastomeric layer; forming a second elastomeric layer on top of a second micromachined mold, the second micromachined mold having a second raised protrusion which forms a second recess extending along a bottom surface of the second elastomeric layer; bonding the bottom surface of the second elastomeric layer onto a top surface of the first elastomeric layer such that a control channel forms in the second recess between the first and second elastomeric layers; and positioning the first elastomeric layer on top of a planar substrate such that a flow channel forms in the first recess between the first elastomeric layer and the planar substrate. <IMAGE>

IPC 1-7
F04B 43/04; **F15C 5/00**

IPC 8 full level
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CPC (source: EP US)
F04B 43/043 (2013.01 - EP US); **F15C 5/00** (2013.01 - EP); **F04B 43/14** (2013.01 - EP US)

Citation (search report)
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